

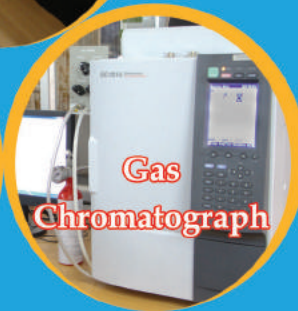
CENTRE FOR RESEARCH IN MATERIAL SCIENCE AND THERMAL MANAGEMENT
DEPARTMENT OF MECHANICAL ENGINEERING



Heat flux Sensor



Plasma facility



Gas Chromatograph

- Facilities
- Testing
- Consultancy

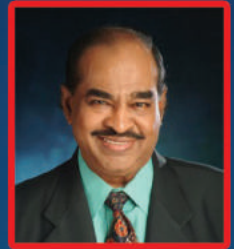


Karunya Institute of Technology & Sciences

Declared as Deemed-to-be University under Section-3 of the UGC Act, 1956

Karunya Founders

The late **Dr. D.G. S. Dhinakaran, C.A.I.I.B., Ph.D.**, the Founder Chancellor Emeritus of Karunya Institute of Technology and Sciences, was a world renowned spiritual leader, accepted by people of all faiths and leaders of many nations. He is the founder of the global Jesus Calls Ministry of which Karunya is just an offshoot. Millions of people all over the world receive hope and solace through his ministry. His vision for Karunya is that of a Technological University founded on faith that will produce teachers, engineers and managers possessing the right combinations of academic excellence, exemplary character and total humanism. The aim is to serve the motherland and fellow men and help raise the quality of life to global standards.



Dr. Paul Dhinakaran, M.B.A., Ph.D., the Chancellor of Karunya Institute of Technology and Sciences spearheads the University. He is an academician and educationalist in his own right. Apart from this he is an evangelist who comforts millions through his ministry of hope and love. He heads Jesus Calls International Ministry with its outreach program all over the world. Dr. Paul Dhinakaran has a vital role to play in the cause of education in India as Member of National Monitoring Committee for Minority Education, Government of India and as member of the Governing Council of National Mission for Sarva Shiksha Abhiyan, Government of India.

Centre for Research in Material Science and Thermal Management, Department of Mechanical Engineering,
Karunya Institute of Technology and Sciences

SL. NO.	CONTENTS	PAGE
1.	Preface	1
2.	Heat Pipe Research Facilities	2
	Leak Detector	3
	Vacuum Pumping System	4
	Heat Pipe Experimental Setup	6
3.	Rotating Heat Pipe Research Facility	7
4.	Plasma Research Facilities	8
5.	Heat Flux Sensor Research Facilities	9
6.	Gas Chromatograph	11
7.	Drop shape analyzer	12
8.	Prusa i3 MK3 kit	13
9	Nanofluid Research facilities	17
10	Other Research Facilities	18

Centre for Research in Material Science and Thermal Management, Department of Mechanical Engineering,
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Preface

Thermal management of systems, especially those of electronics has assumed great importance of late due to the widespread use of computers and microprocessor based control systems. The primary factor which governs the efficiency of the system is the processor speed which is a direct function of the packing density. As shown by the popular Moore's law, this packing density is constantly rising for the processors. However, this increased speed is realized at the cost of a corresponding rise in heat generation which tends to heat up the electronic components. If not controlled appropriately, this increased temperature rise will lead to failure of the electronic component and ultimately to system failures.

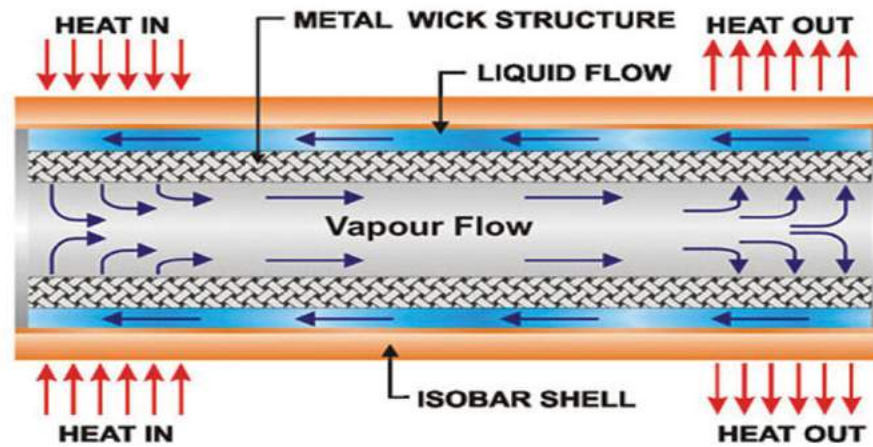
The above scenario has led to intensified attempts worldwide on the subject of thermal management. While for special applications, refrigerated systems could be used, for cooling of a number of electronic products, the ambient air itself could be made use of as the coolant through a mechanism by which the heat generated at source is transported to a point where cooling by ambient air could take place.

Heat pipes play a very important role in the above mechanism of transporting heat from the source to sink in a passive manner, which has led to its development primarily in satellite cooling application. Due to the fact that satellites are not possible to be repaired or serviced during their operation, the use of the heat pipe has been an unqualified success in aerospace applications. However, today the application of heat pipe is not only limited to the aerospace field, but is widespread in terrestrial applications as well, such as in manufacturing, machine tools, biomedical equipment and a host of others which involve electronics and computers.

Karunya Institute of Technology and Sciences has been a pioneer in the field of heat pipe research and development among the engineering institutions of the country. It has a well established laboratory where various types of heat pipes, including thermosyphon, pulsating heat pipes, heat spreaders and a host of other variants of the system are being developed by researchers. This brochure is a short overview of these facilities and activities.

Heat Pipe Research Facilities

A heat pipe is a simple device that can quickly transfer heat from one point to another. Heat pipes can be bent and flattened into a variety of geometries making them ideal for removing heat from high power densely packed electronics.

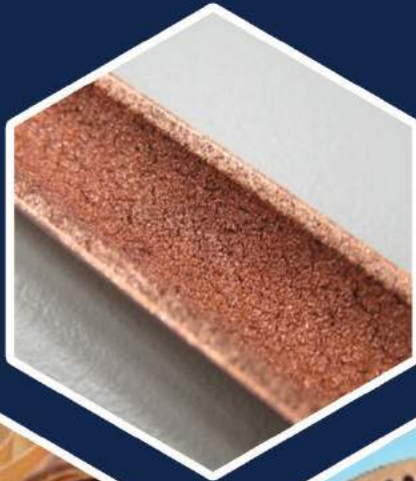


Applications

Heat pipes are used as a cooling device in many industrial applications such as mould cooling, electronic packages cooling, space cooling and reactor cooling etc. Also, heat pipes are used as a heat transfer device in ventilation, heat recovery and solar thermal applications.

Features

- High heat conductivity
- Fast thermal response
- Uniform temperature distribution
- Light weight & compact
- High design possibilities
- No additional power required
- Maintenance free
- No moving parts



Sintered wick



Screen wick



Grooved wick

Helium Leak Detector



Applications

Mass spectrometer leak detector is used for locating and measuring the size of the leak at an enclosure. This equipment can be utilized to ensure the necessary vacuum condition in the heat pipes and vapor chambers.

Specifications

Model	: HMS-P-100L
Make	: Hindivac
Type	: Double stage rotary pump
Pump model	: ED-6
Pump displacement	: 6 m ³ /hr
Power	: 220 V Ac, 50 Hz
Oil charge	: 2 lts

Accessories

- Liquid nitrogen trap
- Roughing valves
- Backing valves
- Throttle valves
- Double stage rotary pump

Features

- Short response and clean-up time
- Laminated top for clean work space
- LN₂ Trap holds charge for 12 hours
- Easy to operate
- Wheels with movable system

Vacuum Pumping System



Applications

The vacuum pumping unit is used to maintain the necessary vacuum condition in the heat pipe and vapor chamber. These systems are also suitable for most of the vacuum applications and low pressure vaporization applications etc.,

Vacuum Pumping System...

Specifications

Model	: Vs-65D
Make	: Hindivac
Range	: Max 10^{-4} milli bar
Pump model	: ED-6
Pump displacement	: 6 m ³ /hr
Oil charge	: 2 lts

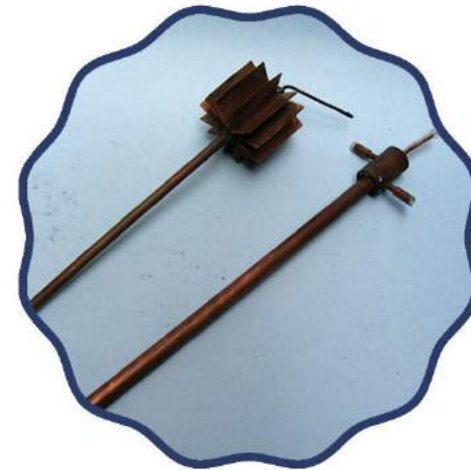
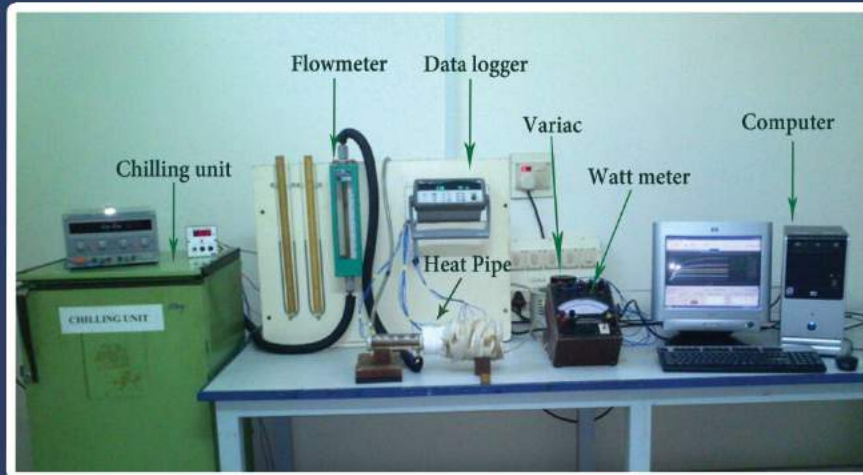
Accessories

- Liquid nitrogen trap
- Water cooled chevron baffle
- Electro pneumatically operated valve (Butterfly valve, right angle valve)
- Push buttons

Features

- All components easily accessible
- Compact construction
- Simple operation
- Allows direct connection of vacuum chamber
- Pumping speed ranging from 120 lps

Heat Pipe - Experimental Set-up



Miniature heat pipe



Vapor chamber



Flat loop heat pipe

Applications

This experimental facility is used to evaluate the heat transfer performance of different types of heat pipes such as cylindrical heat pipes, loop heat pipes, pulsating heat pipes and vapor chambers.

Rotating Heat Pipe Research Facilities



Aluminum
heat pipe



Cylindrical loop
heat pipe



Pulsating
heat pipe



Applications

Fabrication and testing of rotating heat pipes are also carried out in the centre. Generally, the rotating heat pipes are used to cool the compressor shafts, drill bits and machine tools etc. Also, it is used in heat recovery systems in various rotary equipment.

Plasma Research Facilities



Applications

This facility is used to separate the minerals from the ore material. Also, used to make plasma spray coatings and carbothermal reductions.

Accessories

Mass flow controller

Powder feeder

Torch

Graphite crucible

Argon, nitrogen cylinder

Specifications

Make	: Ion-Arc Technologies
Power input	: Max 40 kW
Voltage	: 40 V
Current	: 800 A
Torch type	: Transferred
	: Non - Transferred



Transferred arc



Non - transferred arc

Heat Flux Sensor Calibration Facilities



Black Body Cavity

Specifications

Make	: MIKRON
Model	: M350
Temperature range	: 300 °C to 1500 °C
Power input	: 208-230 V Ac, 60/50 Hz
Cooling method	: Air cooled
Heated cavity shape	: Spherical
Method of Control	: Digital self - tuning PID controller
Operating ambient temperature	: 0 °C to 44 °C
Stability	: 0.5 °C per 8 hour period
Emissivity	: 0.999

Applications

This facility is used to calibrate and test the heat flux sensors.

Black Body Heat Source



Testing with
Heat flux sensors



Testing with
Radiant heat source



Testing with
O₂-H₂ micro flame

Specifications

Range	: 50 °C to 500 °C
Target size	: 57 mm
Resolution	: 0.1 °C
Heating time	: 30 min (50 °C to 500 °C)
Cooling time	: 30 min (500 °C to 100 °C)
Stabilization time	: 10 min
Power	: 115 V Ac, 3 A or 230 V Ac, 1.5 A
Target emissivity	: 0.95

Gas Chromatograph System



Features

- High performance
- Highest precision and accuracy
- Easy operation and flexibility
- Expandability to support all types of analysis

Specifications

Model	: GC - 2014
Make	: Shimadzu
Temperature range	: Max 400 °C
Power requirements	: 1800 VA, 50/60 Hz
Oven capacity	: 15.8 L
Cooling rate	: 300 °C to 50 °C in 6 min

Accessories

- Carrier gas flow controller
- Flame ionization detector
- Thermal conductivity detector
- Flame ionization detector

Gas Chromatograph System...

Applications

The gas chromatograph systems are used for quantitative and qualitative analysis of both liquid and gas samples.

Separating and analysing compounds that can be vapourized without decomposition.

FID measures organic species in a sample mixture at very low and high levels of concentrations.

TCD measures both organic and inorganic compounds concentrations and it is equipped with thin carbon column for simultaneous analysis of inorganic gases like H_2 , O_2 , CO , CH_4 , CO_2 , N_2O , C_2H_2 , C_2H_4 and C_2H_6

Nanofluid Research Facilities



Tensiometer

Applications

The tensiometer is used to measure the surface tension of liquids at the plant or in the laboratory. Also, this device is used to maintain the surfactant concentration in industries.

Tensiometer...

Specifications

Measuring range	: 10-100 mN/m
Resolution	: 0.1 mN/m
Bubble lifetime	: 150-2000 ms
Resolution	: 1 ms
Temperature range	: 0-100 °C
Power supply	: 100 - 240 V : 47 - 63 Hz

Specifications

Model	: LVDV-E
Viscosity range	: Max 100 Cp : 18 spindle speeds
RPM	: 0.3-100
Spring torque	: 0.0673 mN/m
Accuracy	: 0.1% of full scale
Repeatability	: 0.2% of full scale

Viscometer



Applications

The viscometer is used to measure the viscosity of fluids. Such as water, nanofluid and oils at varying temperature.

Ultrasonic Homogenizer

Specifications

Model	: CY-500
Make	: J P Selecta, Spain
Power	: 500 W
Frequency	: 20 kHz

Applications

This equipment is used to prepare various types of nanofluids by suspending ultrafine metallic particles in to the base fluid. Also, this equipment is used to disintegrate the cells and biological tissues etc.



**Ultrasonic homogenizer
(CY-500)**

Thermal Property Analyser

Specifications

Model	: KD2 Pro-40348
Temperature range	: 25-50 °C
Accuracy	: $\pm 2\%$
Types of sensors used	: KS-1, TR-1, SH-1



Thermal property analyser
(KD2 Probe)

Parameters

- Thermal conductivity
- Specific heat of liquids
- Thermal resistivity of slurries and semi solids.

Drop shape analyzer

Make : KRUSS GmbH

Range : 0-1800

Pendent Drop Range : 0.01 to 2000 mN/m

TASKS AND APPLICATIONS

- Characterization of surface pre-treatment processes.
- Testing of the wettability of plastic, glass, ceramic, wood, paper, textiles or metal.
- Testing of surface cleanliness.



Drop shape analyzer

Measuring methods and options

Contact angle between a liquid and a solid

Surface free energy from contact angles of several test liquids using all common models

Static contact angle, advancing angle and receding angle

Measurement of surface tension and liquid-liquid interfacial tension using the Pendant Drop method



Contact angle measurement

Coating Thickness Tester



FEATURES

Make : Metrix +

Model : DFT-F

Range : 0 to 1250 μm

Resolution : 0.1 μm

Temperature Range : 0-50 $^{\circ}\text{C}$

Humidity : < 80%

3D PRINTER

APPLICATION

printing of any material in 3-dimension.

Product Features

Removable magnetic spring steel sheet with PEI surface.

Silent Trinamic drivers with 256 microstepping.

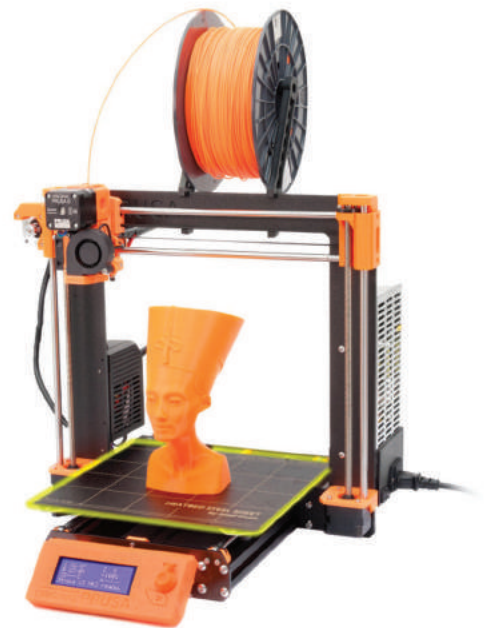
Faster printing: 200+ mm/s.

Sensorless homing for X and Y axes.

Detection and recovery of shifted layers.

Improved frame rigidity with aluminium extrusions.

Better cooling from both sides of the object.



Prusa i3 MK3

HIGH SPEED CAMERA (CHRONOS 1.4)

Highlights

- 1280x1024 1057fps CMOS image sensor with 1.4Gpx/s throughput
- Global shutter LUX1310 image sensor – 8.45 x 6.76mm, 6.6um pixel pitch
- Electronic shutter from 1/fps down to 2us (1/500,000 s)
- Focus peaking (focus assist) and zebra exposure indicator
- ISO 320-5120 (Color), 740-11840 (Monochrome)

APPLICATION

professional high-speed camera in the palm of your hand.

With 1.4 gigapixel-per-second throughput and can capture stunning high-speed video at up to 1280x1024 resolution.

Frame rate ranges from 1,057fps at full resolution, up to 21,600fps at minimum resolution..



Chronos 1.4

FOR FURTHER DETAILS, QUERIES OR CLARIFICATIONS PLEASE CONTACT

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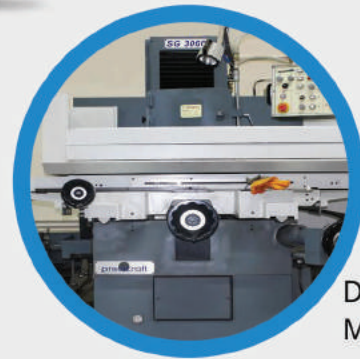
Other Research Centres



Renewable Energy



Metallurgy



Design and
Manufacturing

Programmes Offered

- B.Tech. Mechanical Engineering.
- M.Tech. Engineering Design.
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